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U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT		Docket Number: 52433/861	
Application Number: 10/591,093	Filing Date: August 29, 2006	Examiner: Not Yet Assigned	Art Unit: Not Yet Assigned
Title: METHOD FOR REMOVING BORON FROM SILICON		Applicant(s): Jiro KONDO, et al.	

Address to:
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the
United States Postal Service with sufficient postage as first class mail
in an envelope addressed to:
Mail Stop Amendment
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
on
Date 10-18-06

Sir:

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorney(s) for Applicant(s) hereby bring the reference(s) listed on the attached modified PTO Form No. 1449 to the attention of the Examiner. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.
2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated.
3. It is believed that no fees are due in connection with this Supplemental Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Respectfully submitted,

Dated: *October 18, 2006*

By: *John J. Kelly, Jr.*

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449

DOCKET NO. 52433/861	SERIAL NO. 10/591,093
APPLICANT	
Jiro KONDO, et al.	
FILING DATE August 29, 2006	GROUP Not Yet Assigned

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE*
/SC/	US	5,972,107	Schmid et al.			
/SC/	US	6,368,403	Schmid et al.			

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/SC/	JP 56-32319 A	April 1, 1981	Japan			Partial	
/SC/	JP 58-130114 A	August 3, 1983	Japan			Partial	
/SC/	JP 2003-12317 A	January 15, 2003	Japan			Abstract	
/SC/	JP 4-130009 A	May 1, 1992	Japan			Abstract	
/SC/	JP 4-228414 A	August 18, 1992	Japan			Abstract	
/SC/	JP 5-246706 A	September 24, 1993	Japan			Abstract	
/SC/	JP 4-193706 A	July 13, 1992	Japan			Abstract	
/SC/	JP 9-202611 A	August 5, 1997	Japan			Abstract	
/SC/	WO 89/02415	March 23, 1989	PCT				

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
/SC/	Mitsuru Tanahashi et al., Distribution Behavior of Boron Between SiO ₂ -saturated NaO _{0.5} -CaO-SiO ₂ Flux and Molten Silicon, Journal of the Mining and Materials Processing Institute of Japan, Vol. 118, No. 7, Pages 497-505, 2002

EXAMINER /Stefanie Cohen/	DATE CONSIDERED 07/18/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	